



PATENT
Attorney Docket No. TI-31133
Application No.: 10/001,483
Customer No.: 23,494

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Antonio ROTONDARO) Group Art Unit: 2823
Application No.: 10/001,483) Examiner: Michelle Estrada
Filed: November 1, 2001)
For: METHOD TO IMPROVE THE)
UNIFORMITY AND REDUCE THE)
SURFACE ROUGHNESS OF THE)
SILICON DIELECTRIC)
INTERFACE)

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated January 16, 2004, the period for reply having been extended for one month by a request for extension (May 16, 2004, being a Sunday) and fee payment filed concurrently herewith, Applicant respectfully submits the following remarks:

Remarks begin on page 2 of this paper.